



PATENT
Attorney Docket No. 02887.0246

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Takahiro IKEDA)
)
Application No.: 10/644,001)
) Group Art Unit: 2624
Filed: August 20, 2003)
) Examiner: Daniel G. Mariam
For: EXTRACTING METHOD OF)
PATTERN CONTOUR, IMAGE)
PROCESSING METHOD,)
SEARCHING METHOD OF)
PATTERN EDGE, SCANNING) Confirmation No.: 4850
METHOD OF PROBE,)
MANUFACTURING METHOD OF)
SEMICONDUCTOR DEVICE,)
PATTERN INSPECTION)
APPARATUS, AND PROGRAM)

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed March 1, 2007, the period for response to which has been extended to August 1, 2007, by a Petition for Extension of Time of two months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Amendments to the Drawings are included in the attached replacement drawing sheet.

Remarks follow the amendment sections of this paper.

Attachments to this amendment include a Replacement Sheet 26/44 (including FIGS. 26A-E).